

Title (en)

ELECTRO-MECHANICAL COMPONENT AND METHOD FOR PRODUCING THE SAME

Title (de)

ELEKTROMECHANISCHES BAUELEMENT UND VERFAHREN ZUR HERSTELLUNG DESSELBEN

Title (fr)

COMPOSANT ELECTROMECANIQUE ET SON PROCEDE DE PRODUCTION

Publication

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Application

**EP 00971334 A 20001006**

Priority

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Abstract (en)

[origin: WO0127026A1] The invention relates to an electromechanical component (10) comprising a polymeric body (12) consisting of a mechanically active component (14a, 14b, 14c), a frame (18) and a metal layer (30). Said metal layer at least partially covers a mechanically active part in order to mechanically stabilize the same, whereby a region of the polymer body (12) carrying said metal layer (30), comprises a first polymer material which can be metallized in a wet chemical process. Another region which does not have a metal layer comprises a second polymer material which can not be metallized in a wet chemical process. Said electromechanical component can be an acceleration sensor, a rotation speed sensor, a microvalve, a micropump, a pressure sensor or a power sensor. Production of said electromechanical component incurs substantially lower costs compared to electromechanical components produced using silicon-based technology because said production process involves simple injection-molding and/or stamping instead of complicated silicon-based technology.

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